



Attorney's Docket No.: 042390.P4220

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Bohr, Mark T.

U.S. Serial No: 09/002,178

Filed: December 31, 1997

For: WAFER PASSIVATION  
STRUCTURE AND METHOD OF  
FABRICATION

Examiner: Guerrero, Maria F.

Art Unit: 2822

Assistant Commissioner for Patents  
Washington, D.C. 20231

#26  
2-403  
Patent  
RECEIVED  
FEB - 3 2003  
TECHNOLOGY CENTER 2800

PRELIMINARY AMENDMENT

Dear Sir:

Please enter the enclosed Preliminary Amendment and consider the following remarks prior to examination of the above-referenced case.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on January 22, 2003

Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Signature

Date

Serial No.: 09/002,178

Attorney Docket: 042390P4220